

Notice of References Cited	Application/Control No. 10/725,426	Applicant(s)/Patent Under Reexamination SIMONS ET AL.	
	Examiner Lisa Herring	Art Unit 1731	Page 1 of 1

U.S. PATENT DOCUMENTS

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	A	US-4,608,070	08-1986	Roba, Giacomo	65/420
	B	US-4,664,689	05-1987	Davis, Robert B.	65/434
	C	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Geittner et al., "PCVD at High Deposition Rates", Journal of Lightwave Technology, Vol. LT-4, No. 7, July 1986, pg. 818-821.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.